



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

November 29, 2025

IGI Report Number **LG752580716**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **9.11 - 9.17 X 5.81 MM**

#### GRADING RESULTS

Carat Weight **3.00 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

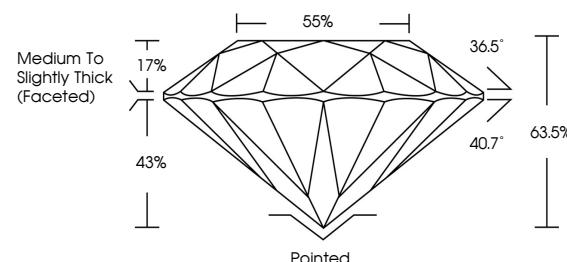
Inscription(s) **IGI LG752580716**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

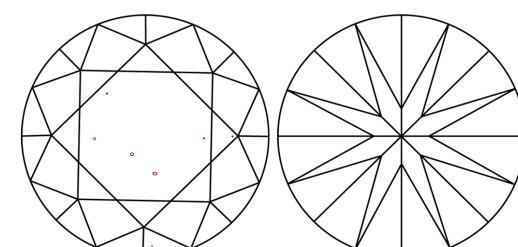
Type Ila

LG752580716  
Report verification at [igi.org](https://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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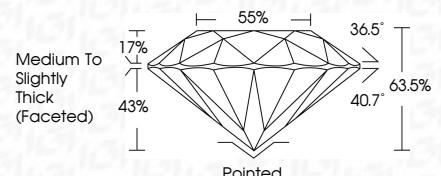
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Sample Image Used



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**IGI**



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	9.11 - 9.17 X 5.81 MM	
Carat Weight	3.00 CARATS	
Color Grade	E	
Clarity Grade	VS 1	
Cut Grade	EXCELLENT	
Depth	63.5%	
Table	69%	
Girdle	Medium to Slightly Thick (Faceted)	
Polish	EXCELLENT	
Symmetry	EXCELLENT	
Fluorescence	NONE	
Inscription(s)	IGI LG752580716	

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